#### The significance of the defocus ATF



## The significance of the defocus ATF





Even though our derivations were carried out for *spatially coherent* imaging, the same arguments and results apply to the (more common) *spatially incoherent* case

## The significance of DoF in imaging



## Numerical examples: the object



focal plane



## Intensity image: noise-free





## Can the blur be undone computationally?

• The effect of the optical system is expressed in the Fourier domain as a product of the object spectrum times the ATF:

 $G_{\mathrm{I}}^{\mathrm{out}}(u,v) = G_{\mathrm{I}}^{\mathrm{in}}(u,v) \times \mathcal{H}(u,v)$ 

at best, diffraction-limited ATF; it may also include the effect of defocus and higher-order aberrations

• Therefore, if we multiply the image spectrum by the inverse ATF, we should expect to recover the original object:

$$G_{\mathrm{I}}^{\mathrm{in,recovered}}(u,v) = G_{\mathrm{I}}^{\mathrm{out}}(u,v) \times \frac{1}{\mathcal{H}(u,v)}$$

this is referred to as "inverse filtering" or "deconvolution"

- However, direct inversion never works because:
  - the ATF may be zero at certain locations, whence the inverse filter would blow up
  - the image intensity measurement always includes noise;
     the inverse filter typically amplifies the noise more than the true signal, leading to nasty artifacts in the reconstruction



## Tikhonov-regularized inverse filter

• The following inverse filter behaves better than the direct inversion:

$$G_{\mathrm{I}}^{\mathrm{in,Tikhonov}}(u,v) = G_{\mathrm{I}}^{\mathrm{out}}(u,v) \times \frac{\mathcal{H}^{*}(u,v)}{\left|\mathcal{H}(u,v)\right|^{2} + \mu}$$

- for  $\mu$ =0, it reduces to the direct filter (not a good idea)
- the value of  $\mu$  should be monotonically increasing with the amount of noise present in the intensity measurement
  - e.g. if the noise is vanishingly small then we expect direct inversion to be less problematic so a small value of μ is ok; however, the problem of zeros in the ATF remains so μ≠0 is still necessary
  - if the noise is strong, then a large value of  $\mu$  should be chosen to mitigate noise amplification at high frequencies
  - in the special case when both signal and noise obey Gaussian statistics, it can be shown that the optimal value of μ (in the sense of minimum quadratic error) is 1/SNR; this special case of a Tikhonov regularizer is also known as a Wiener filter



## Tikhonov regularized inverse filter, noise-free



Deconvolution using Tikhonov regularized inverse filter Utilized *a priori* knowledge of depth of each digit (alternatively, needs depth-from defocus algorithm)

Artifacts due primarily to numerical errors getting amplified by the inverse filter (despite regularization)



## Intensity image: noisy

<u>SNR=10</u>





## Tikhonov-regularized inverse filter with noise





Deconvolution using Wiener filter (i.e. Tikhonov with  $\mu$ =1/SNR=0.1) Noise is destructive away from focus (especially at 4DOFs) Utilized *a priori* knowledge of depth of each digit

Artifacts due primarily to noise getting amplified by the inverse filter



## Today

- Polarization
  - the vector nature of electromagnetic waves revisited
  - basic polarizations: linear, circular
  - wave plates
  - polarization and interference
- Effects of polarization on imaging
  - beyond scalar optics: high Numerical Aperture
  - engineering the focal spot with special polarization modes



#### **Vector nature of EM fields**

Recall the vectorial nature of the EM wave equation:

$$\nabla^2 \mathbf{E} - \mu_o \epsilon_0 \frac{\partial^2 \mathbf{E}}{\partial t^2} = 0.$$

The polarization is given by the constitutive relationship:  $\mathbf{P} = f(\mathbf{E})$ 

linear, isotropic 
$$\mathbf{P} = \chi \mathbf{E}$$
 index of refraction  
 $n = \sqrt{1 + \chi}$ 

linear, anisotropic 
$$\mathbf{P} = \begin{pmatrix} \chi_{11} & \chi_{12} & \chi_{13} \\ \chi_{21} & \chi_{22} & \chi_{23} \\ \chi_{31} & \chi_{32} & \chi_{33} \end{pmatrix} \mathbf{E}$$
 The index of refraction (phase delay) depends on the polarization

non-linear, isotropic 
$$\mathbf{P} = \chi_1 \mathbf{E} + \chi_3 |\mathbf{E}|^2 \mathbf{E}$$
  
 $\chi_3$ : Kerr coefficient The index of refraction  
(phase delay) depends on  
the intensity















## **Circular polarization**







### $\lambda$ /4 wave plate



birefringent  $\lambda/4$  plate

*Circular polarization* 



## $\lambda/2$ wave plate



birefringent  $\lambda/2$  plate

Linear (90°-rotated) polarization







#### **Polarization and interference**



#### Intensity in focal region

Image removed due to copyright restrictions. Please see Fig. 2 in Linfoot, E. H., and Wolf. "Phase Distribution Near Focus in an Aberration-Free Diffraction Image."*Proceedings of the Physical Society B* 69 (August 1956): 823-832.

Assumes:

- Small angles (paraxial)
- N large (Debye approximation)

#### McCutchen JOSA 54, 240-244 (1964)

![](_page_23_Figure_1.jpeg)

3-D point spread function *h* is 3-D Fourier transform of 3-D pupil (cap of spherical shell, Ewald sphere)

#### **Two cases for Debye approximation**

![](_page_24_Figure_1.jpeg)

#### Li and Wolf: finite Fresnel number Debye approximation not valid

#### Diffraction of converging wave by an aperture (paraxial theory)

Image removed due to copyright restrictions. Please see Fig. 4b in Li, Yajun, and Emil Wolf. "Three-dimensional intensity distribution near the focus in systems of different Fresnel numbers." *Journal of the OSA A* 1 (August 1984): 801-808.  $U_N(P) = B_N(u_N) \exp[i\Phi_N(u_N, v_N)]$  $\times \int_0^1 J_0(v_N\rho) \exp(-iU_N\rho^2/2)\rho d\rho,$ 

$$u_N = 2\pi N \frac{z/f}{1 + z/f},$$
$$v_N = 2\pi N \frac{r/a}{1 + z/f}.$$

$$u_N = \frac{u}{1 + u/2\pi N} \qquad u = \frac{2\pi}{\lambda} \left(\frac{a}{f}\right)^2 z,$$
$$v_N = \frac{v}{1 + u/2\pi N} \qquad v = \frac{2\pi}{\lambda} \left(\frac{a}{f}\right) r,$$

![](_page_25_Figure_6.jpeg)

# Maximum in intensity no longer at focus - focal shift

Three-dimensional intensity distribution near the focus in systems of different Fresnel numbers

Vol. 1, No. 8/August 1984/J. Opt. Soc. Am. A 801

## **Tight focusing of light**

Microscopy

Laser micromachining and microprocessing

- Optical data storage
- Optical lithography
- Laser trapping and cooling
- Physics of light/atom interactions
- •Cavity QED

#### Focusing by high numerical aperture (NA) lens (Debye approximation)

![](_page_27_Figure_1.jpeg)

## A plane polarized wave after focusing: Polarization on reference sphere

direction of propagation

![](_page_28_Figure_2.jpeg)

- $\mathbf{p}_x$  (electric dipole along *x* axis)
- **m**<sub>v</sub> (magnetic dipole along *y* axis)
- C is nearly linear polarization
- Richards & Wolf polarization

#### **Richards and Wolf, 1959** Angular spectrum of plane waves

$$\begin{split} e_x(P) &= -\operatorname{i} A(I_0 + I_2 \cos 2\phi_P), \\ e_y(P) &= -\operatorname{i} A I_2 \sin 2\phi_P, \\ e_z(P) &= -2A I_1 \cos \phi_P, \end{split} \right\}$$

where

$$\begin{split} I_{0} &= I_{0}(kr_{P},\theta_{P},\alpha) = \int_{0}^{\alpha} \cos^{\frac{1}{2}}\theta \sin\theta(1+\cos\theta) J_{0}(kr_{P}\sin\theta\sin\theta_{P}) e^{ikr_{P}\cos\theta\cos\theta_{P}} d\theta, \\ I_{1} &= I_{1}(kr_{P},\theta_{P},\alpha) = \int_{0}^{\alpha} \cos^{\frac{1}{2}}\theta \sin^{2}\theta J_{1}(kr_{P}\sin\theta\sin\theta_{P}) e^{ikr_{P}\cos\theta\cos\theta_{P}} d\theta, \\ I_{2} &= I_{2}(kr_{P},\theta_{P},\alpha) = \int_{0}^{\alpha} \cos^{\frac{1}{2}}\theta \sin\theta(1-\cos\theta) J_{2}(kr_{P}\sin\theta\sin\theta_{P}) e^{ikr_{P}\cos\theta\cos\theta_{P}} d\theta. \end{split}$$
(2.32)

Aplanatic factor

*I*<sub>2</sub>: cross-polarization component *I*<sub>1</sub>: longitudinally-polarized component

#### **Focal plane for aplanatic**

Image removed due to copyright restrictions. Please see Fig. 5 in Sheppard, C. J. R, A. Choudhury, and J. Gannaway. "Electromagnetic field near the focus of wide-angular lens and mirror systems." *IEE Journal on Microwaves, Optics, and Acoustics* 1 (July 1977): 129-132. Not circularly symmetric

Electromagnetic field near the focus of wide-angular lens and mirror systems

C.J.R. Sheppard, A. Choudhury and J. Gannaway

#### Focus of an aplanatic lens

Image removed due to copyright restrictions. Please see Fig. 6 in Sheppard, C. J. R., and P. Török. "Efficient calculation of electromagnetic diffraction in optical systems using a multipole expansion." *Journal of Modern Optics* 44 (1997): 803-818.

C. J. R. SHEPPARD and P. TÖRÖK

## Efficient calculation of electromagnetic diffraction in optical systems using a multipole expansion

JOURNAL OF MODERN OPTICS, 1997, VOL. 44, NO. 4, 803-818

#### **Bessel Beam**

## Annular mask

Axicon (McLeod, 1954)

# Diffractive axicon (Dyson, 1958)

![](_page_32_Figure_4.jpeg)

![](_page_32_Figure_5.jpeg)

### **Bessel beam**

 $J_0$  beam propagates without spreading:

#### A wave with zeroorder Bessel-function radial distribution propagates without

change.

C. J. R. Sheppard and T. Wilson, "Gaussian-beam theory of lenses with annular aperture," IEE J. Microwaves, Opt. Acoust. 2, 105–112 (1978).

Image removed due to copyright restrictions. Please see Fig. 2 in Sheppard, C. J. R. "Electromagnetic field in the focal region of wide-angular annular lens and mirror systems." *IEE Journal of Microwaves, Optics, and Acoustics* 2 (September 1978): 163-166.

> Time-averaged electric energy density for plane polarized illumination

(e.g. with mirror)

C. J. R. Sheppard, "Electromagnetic field in the focal region of wide-angular annular lens and mirror systems," IEE J. Microwaves, Opt. Acoust. 2, 163–166 (1978).

## Annulus at high NA: circular polarization or TM0 (radial polarization)

![](_page_34_Figure_1.jpeg)

•Paraxial: annulus narrower than Airy

High NA: circular polarized annulus is ~ same width as Airy
High NA: TMO annulus is similar to paraxial Annular pupils, radial polarization, and superresolution

Colin J. R. Sheppard and Amarjyoti Choudhury

#### **Polarization on reference sphere**

![](_page_35_Figure_1.jpeg)

#### Radial polarization with phase mask

Images removed due to copyright restrictions. Please see Fig. 2, 4, in Wang, Haifeng, et al. "Creation of a Needle of Longitudinally Polarized Light in Vacuum Using Binary Optics." *Nature Photonics* 2 (August 2008): 501-505.

## Electric dipole wave: Ratio of focal intensity to power input

![](_page_37_Figure_1.jpeg)

C. J. R. Sheppard and P. Török,

"Electromagnetic field in the focal region of an electric dipole wave," Optik **104**, 175-177 (1997).

![](_page_38_Figure_0.jpeg)

## **Bessel beams: TE1 polarization**

![](_page_39_Picture_1.jpeg)

#### **Polarization on reference sphere**

![](_page_40_Figure_1.jpeg)

![](_page_41_Figure_0.jpeg)

Polarization of input wave

(azimuthally polarized) (radially polarized)

#### Area of focal spot

![](_page_42_Figure_1.jpeg)

## **Rotationally symmetric beams**

TM0 = radial polarized input (longitudinal field in focus)

```
•TE0 = azimuthal polarization
```

```
•x polarized + i y polarized = circular polarized
```

```
•TE1<sub>x</sub> + i TE1<sub>y</sub> = azimuthal polarization with a phase singularity (bright centre)
```

•ED<sub>x</sub> + i ED<sub>y</sub> = elliptical polarization with a phase singularity (bright centre)

•(TM1<sub>x</sub> + *i* TM1<sub>y</sub> = radial polarization with a phase singularity)

```
•Same G_T as for average over \phi
```

## Bessel beams: Transverse behaviour for rotationally symmetric (also average over φ)

![](_page_44_Figure_1.jpeg)

#### Normalized width for rotationally symmetric

![](_page_45_Figure_1.jpeg)

TE = azimuthal polarization with phase singularity (vortex)

# Bessel beams for rotationally symmetric

![](_page_46_Figure_1.jpeg)

## Conclusions

- •Focusing plane polarized light results in a wide focal spot
- Focusing improved using radially polarized illumination
- Strong longitudinal field on axis
- •Electric dipole polarization gives higher electric energy density at focus
- •Transverse electric (TE1) polarization gives smallest central lobe (smaller than radial for Bessel beam)
- •TE is asymmetric: symmetric version is azimuthal polarization with a phase singularity (vortex)

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